IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT

APPLICANT: Stefan Thesen   CONFIRMATION NO.: 5388

SERIAL NO.:   10/720,721   GROUP ART UNIT: 1764

FILED: November 24, 2003

TITLE: "METHOD AND DEVICE FOR FAST PROCESSING OF MEASUREMENT DATA WITH A PLURALITY OF INDEPENDENT RANDOM SAMPLES"

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

S I R:

In accordance with the provisions of 37 C.F.R. § 1.56, Applicant requests that citation and examination of the following documents be made during the course of examination of the above-referenced application.

AT   "Simultaneous Registration and Activation Detection for fMRI," Orchard et al., Magnetic Resonance in Medicine (online), April 2002

AU   "Real-Time Multiple Linear Regression for fMRI Supported by Time-Aware Acquisition and Processing," Smyser et al., Magnetic Resonance in Medicine, Vol. 45, No. 2 (2001) pages 289-298

EXPLANATION OF RELEVANCE

The above references were cited by the German Patent and Trademark Office in connection with examination of the counterpart German application.

Copies of each of the above references together with Form 1449 are submitted herewith.

The PTO did not receive the following listed Items(s) NPL

As of the date of mailing of this Information Disclosure Statement, a first Office Action on the merits has not been received in connection with this application, and therefore, this Information Disclosure Statement is in compliance with 37 C.F.R. §1.97(b)(3), and no fee is necessary.

Should this Information Disclosure Statement cross in the mail with a first Office Action, it is still in compliance with 37 C.F.R.§ 1.97(c), and no fee is necessary. Accordingly, the undersigned counsel states, pursuant to 37 C.F.R.§ 1.97(e)(1), that each of the above references was first cited in a communication from a foreign patent office in connection with a foreign application not more than three months prior to the filing of this information disclosure statement.

All claims of the application are submitted to be patentable over the teachings of the above references, taken singly or in combination, or in combination with any of the other previously submitted references. Early consideration of the application is therefore respectfully requested.

Submitted by,

Steven H. Noll (Reg. 28,982)

SCHIFF, HARDIN LLP, **CUSTOMER NO. 26574**
Patent Department, 6600 Sears Tower
233 South Wacker Drive
Chicago, Illinois 60606
Telephone: 312/258-5790
Attorneys for Applicant.

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450 on June 28, 2005.

Steven H. Noll

STEVEN H. NOLL

-2-

Form PTO-1449		Docket No. P03,0473				Serial No. 10/720,721	
INFORMATION DISCLOSURE CITATION IN AN APPLICATION (use several sheets if necessary)		Applicant Stefan Thesen					
		Filing Date November 24, 2003`				Group Art Unit 1764	

U.S. PATENT DOCUMENTS

Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							
	AQ							
	AR							
	AS							

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

	AT	"Simultaneous Registration and Activation Detection for fMRI," Orchard et al., Magnetic Resonance in Medicine (online), April 2002
	AU	Website Printout for Statistical Parametric Mapping Software, (SPM99) (January 25, 2000)
	AV	"Real-Time Multiple Linear Regression for fMRI Supported by Time-Aware Acquisition and Processing," Smyser et al., Magnetic Resonance in Medicine, Vol. 45, No. 2 (2001) pages 289-298
	AW	
	AX	
	AY	
	AZ	

Examiner	Date Considered

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

CHI\ 4294137.1